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Type 649B

ELECTRONIC PRESSURE CONTROLLER[™] WITH MASS-FLO[®] METER

The MKS Type 649B is the RoHS-compliant version of the industry standard Type 649 instrument that provides both pressure control and flow metering. The Type 649 replaces multiple component subassemblies, for example pressure controllers with separate flow meters used in applications such as backside wafer cooling systems (BWCS). The compact Type 649 design allows for significant reduction in BWCS size and complexity.

The 649 Series Pressure Controller contains a capacitance manometer, mass flow meter, normally-closed proportioning control valve, and closed-loop control electronics. The Type 649 controls absolute pressure. The pressure transducer is a Baratron[®] Capacitance Manometer, with Full Scale pressure ranges from 10 Torr to 1000 Torr. Baratron Capacitance Manometers – well-known for their percent of Reading accuracy, stability, and resolution – provide precise measurements at lower pressures and over wider dynamic ranges than strain gage transducers. The patented mass flow sensor provides exceptional zero stability and accuracy of flow measurement. Full Scale ranges from 10 sccm to 5000 sccm nitrogen equivalent are available.

The 649 is powered by ± 15 VDC at only 300 mA. The default pressure output and input control signals are 0-10 VDC. Two trip points are included in the 649, with LED status indicators, for use as simple on/off process limits. The 649's control loop tuning parameters are preset for typical installation conditions, but are field adjustable for different conditions and optimum performance. The Proportional and Integral Term adjustments are simple rotary switches, providing a wide dynamic control range.

In the Type 649, a pressure transducer monitors the pressure to be controlled at the downstream end of the controller. Actual pressure is compared in the electronics to the pressure set point signal. An appropriate signal is then generated to adjust the proportioning control valve to bring actual pressure into agreement with the desired set point. The internal control valve can be specified with one of four orifices allowing pressure control in systems with Full Scale flows from 10 sccm to 5 slm.

Features & Benefits

Designed For The Most Demanding Processes

- · Backside wafer cooling
- Fast response to set point with minimal overshoot
- Metal-sealed, cleanroom manufactured units meet critical high purity application needs

Reliable, Rugged, Repeatable

- Integral Baratron[®] Capacitance Manometer provides accuracy, reliability, and wide range
- Patented mass flow sensor* provides exceptional long-term accuracy and zero stability

Easily Integrated

- Integral pressure measurement and control with flow metering in a single package requires less space and reduces system cost
- Two alarm trip points for process limit control
- CE Mark compliant meets requirements for European Union

*US Patent 5461913. Foreign patent pending.

Pressure Range

In the Type 649 Controller, the Baratron® Pressure Transducer measures absolute pressure. Full Scale ranges of 10, 100, or 1000 Torr are available. Each 649 can control pressure from Full Scale to less than 2% of Full Scale. Prudent design suggests choosing the lowest possible Full Scale for the application, taking into consideration the overpressure to which the sensor may be exposed (both normal and accidental).

Valve Orifice

The flow through any orifice depends on the size of the orifice, the inlet and outlet pressures, and gas density. To simplify 649 orifice selection, use the following procedure:

1. On the Index Number Table in Figure 1, choose your inlet pressure from the column of pressures on the left–the pressure that will be applied to the inlet of your 649. (Note that the values are absolute pressure.)

Next, from the row of pressures at the top of that table, select your differential (delta) pressure – this is the inlet pressure minus your outlet pressure.

Locate the Index Number – where your selected row and column intersect.

2. If you are using N₂, skip to step #3. For other gases, calculate the Density Correction Factor (DCF) by the following formula:

DCF =
$$\sqrt{\frac{N_2 \text{ Density}}{\text{User Gas Density}}}$$

Multiply this Density Correction Factor times the Index Number found in step 3, to determine your density-corrected Index Number.

3. Go to the Orifice Selection Graph (Figure 2) and locate your Index Number along the bottom axis.

Draw a vertical line at your Index Number. This line will intersect with the Max. Flow Rate lines for available valve orifices.

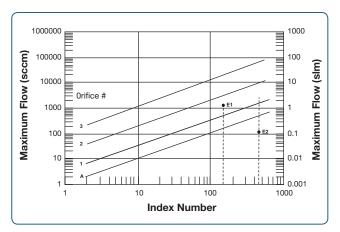
Choose the orifice whose maximum flow rate exceeds your requirements.

Example 1

You want to control your process pressure at 5 psia (250 Torr), with a maximum flow rate of 1000 sccm of N_2 . The process connections are 4VCR and a Viton valve plug is specified. Your inlet pressure is 15 psig (30 psia) giving a differential pressure (delta P) of 25 psi. Approximating your differential pressure as 30 psi gives an Index Number of 175. Drawing a vertical line on the Orifice Selection Chart at 175 indicates that a #2 orifice (•E1) would be best choice for the application. The P/N for this model is 649B01313T23C2VR.

| | Differential Pressure (psi) | | | | | | | | | | |
|------------------------------|-----------------------------|------|------|-----|-----|-----|-----|------|------|------|--------|
| | >50 | 50 | 30 | 15 | 8 | 4 | 2 | 1 | 0.5 | | |
| 100 | >585 | 585 | 480 | 355 | 265 | 190 | 135 | 95 | 65 | 5170 | |
| (psia) 30 | - | 295 | 295 | 240 | 185 | 130 | 95 | 65 | 50 | 2585 | Ē |
| | - | - | 175 | 175 | 140 | 100 | 75 | 50 | 40 | 1551 | (Torr) |
| 20 Lessare 10 | - | - | - | 115 | 110 | 80 | 60 | 40 | 30 | 1034 | ar |
| S 15 | - | - | - | 90 | 90 | 70 | 50 | 35 | 25 | 776 | essure |
| | - | - | - | - | 60 | 55 | 40 | 30 | 20 | 517 | Pre |
| 1 5 2 | - | - | - | - | - | 30 | 25 | 20 | 15 | 259 | Inlet |
| <u> </u> | - | - | - | - | - | - | 10 | 10 | 9 | 103 | 르 |
| 1 | - | - | - | - | - | - | - | 6 | 6 | 51.7 | |
| | >2585 | 2585 | 1551 | 776 | 414 | 207 | 103 | 51.7 | 25.9 | | |
| Differential Pressure (Torr) | | | | | | | | | | | |

Figure 1 – Index Number Table





Example 2

You want to control your process pressure at 5 Torr (0.1 psia), with a maximum flow rate of 100 sccm He. The process connections are 8VCR and a Viton valve plug is specified. Your inlet pressure is 15 psig (30 psia) giving a differential pressure (delta P) of 30 psi. Approximating your differential pressure as 30 psi again gives an uncorrected Index Number of 175. The density of N₂ is 1.25 and the density of He is 0.179 giving a Density Correction Factor of 2.6. Multiplying the uncorrected Index Number by the Density Correction Factor gives a density corrected Index Number of 455. Drawing a vertical line on the Orifice Selection Chart at 455 indicates that a size A orifice (•E2) would be best choice for the application. The P/N for this model is 649B00111T12CAVT.

Note: The above procedure is a useful tool for most typical configurations and applications. If your particular pressure control application falls outside these parameters, please contact our Applications Engineers for assistance in selecting the proper instrument configuration.

Specifications

Pressure Controller Type Pressure Ranges (Full Scales) Flow Ranges (Full Scales) Transducer Overpressure Limit Orifice Full Scale Ranges

Maximum Differential Pressure Pressure Control Mode

Pressure Reading

Accuracy Temp. Coefficients

Time Response

Pressure Control Range Accuracy Time Response

Flow Reading

Measurement Range Accuracy (including non-linearity, hysteresis, and non-repeatability referenced to 760 mmHg and 0°C) Repeatability Resolution Temperature Coefficients

Pressure Coefficient Meter Warm-up Time (w/in 0.2% of F.S. steady state) **Meter Response Time Operating Temperature Storage Temperature Power Required Input/Output Signals** Connector **Cable Length RFI Sensitivity Trip Points** Pressure Rated Adjustable Hysteresis Indicators **Approvals & Certifications Restriction of Hazardous Substances** Materials Exposed to Gas Standard (metal sealed) Optional (valve plug) Leak Integrity External

Internal (through closed valve)*

Fittings (compatible with) Dimensions Weight

Type 649B

10, 20, 50, 100, 1000 mmHg (Torr) 10, 20, 50, 100, 200, 500, 1000, 2000, 5000 sccm 45 psia or 2x F.S., whichever is greater 50, 200, 1000, 5000 sccm (nominal F.S. flow rates for N, with 15 psig on inlet and atmospheric pressure on outlet) 150 psi (consistent with transducer overpressure limit) Downstream ±0.5% of Reading (includes linearity, hysteresis, and repeatability) Zero: ±0.04% of F.S./°C Span: ±0.04% of Reading/°C <100 msec 2 to 100% of F.S. ±0.2% of F.S. 1.0 sec (excluding systemtime constant) 1% to 100% of F.S. ±1.0% of F.S. ±0.2% of F.S. 0.1% of F.S. Zero: < 0.05% of F.S./°C Span: < 0.08% of Rdg./°C <0.02% of Rdg./psi <2 min <100 msec 0° to 50°C (32° to 122°F) -20° to 80°C (-4° to 176°F) ±15 VDC ±5%, 300 mA max. Pressure: 0-10 VDC default (user settable to 0-5 VDC) 15-pin male Type "D" 100 ft. (30 m) max. SAMA 33.1, 1-abc: <0.2% of F.S. Two open-collector transistors 250 mA @ 30 VDC 1 to 100% of F.S. 3% of E.S. Green LED's on when actuated CE Compliant to EMC Directive 2004/108/EC (when used with an overall metal braided shielded cable, properly grounded at both ends) Fully compliant to RoHS Directive 2002-95-EC 316L S.S., 316L/VAR S.S., Inconel®, Nickel Viton[®], Kalrez[®], Kel-F[®], or metal < 10⁻⁹ scc/sec He

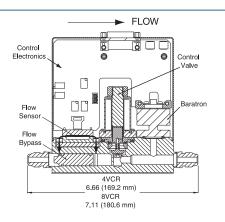
Elastomer valve: < 10-3 scc/sec He Kel-F/metal valve: < 2% of F.S. (N₂ @ 25 psig to atm.) Male Swagelok[®] 4 VCR[®], 8 VCR 1.5" (38.1 mm) x 6.66" (169.2 mm) (4 VCR) x 5.50" (140 mm) max. 3.5 lbs. (1.59 kg)

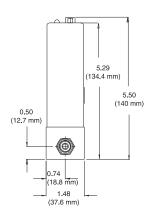
Note: The 649 Series controllers require flow to operate, but will not control pressure in "dead-ended" (zero flow) applications.

*Type 649 Control Valves should not be used for positive shutoff. Where positive shutoff is required, a separate valve should be installed. When selecting the location of an external shutoff valve, consideration should be given to the maximum pressure rating of the internal transducer and to the possibility that leakage across the internal valve over time can build up and result in a sudden surge of gas.



Ordering Information





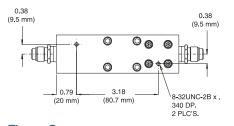


Figure 3 —

Cross section diagram. Note: unless otherwise specified, dimensions are nominal values in inches (mm referenced).

| 5 I | | 0 |
|--|--------|------------|
| Types 649 Electronic Pressure Controller with MFM | 649B | 649B |
| Gas | | |
| Helium (He) | 001 | |
| Argon (Ar) | 004 | 004 |
| Hydrogen (H ₂) | 007 | 004 |
| Nitrogen (N ₂) | 013 | |
| Pressure Range Full Scale | | |
| 10 Torr (mmHg) | 11T | |
| 20 Torr (mmHg) | 21T | |
| 50 Torr (mmHg) | 51T | 13T |
| 100 Torr (mmHg) | 12T | |
| 1000 Torr (mmHg) | 13T | |
| Flow Rate | | |
| 10 sccm | 11C | |
| 20 sccm | 21C | |
| 50 sccm | 51C | |
| 100 sccm | 12C | |
| 200 sccm | 22C | 12C |
| 500 sccm | 52C | .20 |
| 1000 sccm | 13C | |
| 2000 sccm | 23C | |
| 5000 sccm | 53C | |
| Valve Orifice (nominal F.S. flow range for N, at 1 atm | ո. DP) | |
| A (50 sccm) | A | |
| #1 (200 sccm) | 1 | |
| #2 (1000 sccm) | 2 | 2 |
| #3 (5000 sccm) | 3 | |
| Valve Plug Material | | |
| Viton | V | |
| Kalrez | D | |
| Metal* | Μ | V |
| Kel-F | F | |
| Fittings (compatible with) | | |
| Swagelok 4 VCR male | R | _ |
| Swagelok 8 VCR male | Т | R |
| Optional Accessories | | |
| Type 246 single-channel power supply/readout/set | 246C | |
| Type 247C four-channel power supply/readout/set p | 247D | |
| Type 649 Y cable | | CB649-1-M1 |
| | | |

Code

Configuration

* Metal valve plug available on 200 sccm and larger valve orifice

Ordering Code Example: 649B00413T12C2VR



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